

FIG. 1A

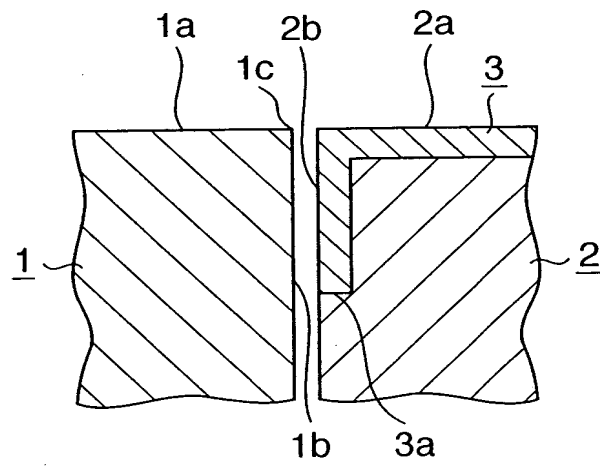


FIG. 1B

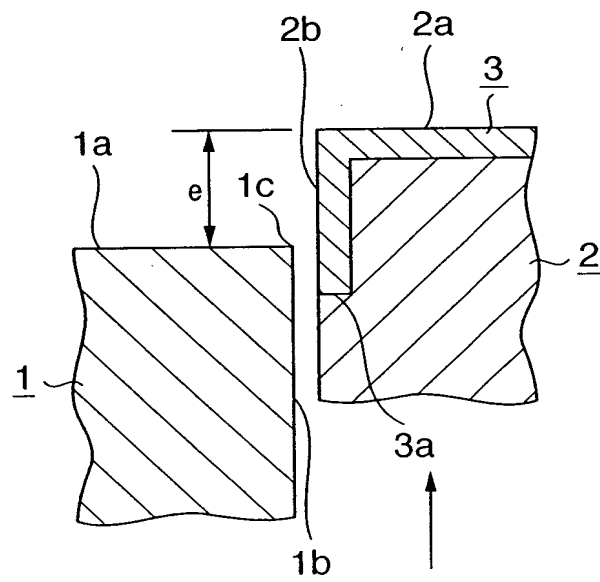


FIG. 2A

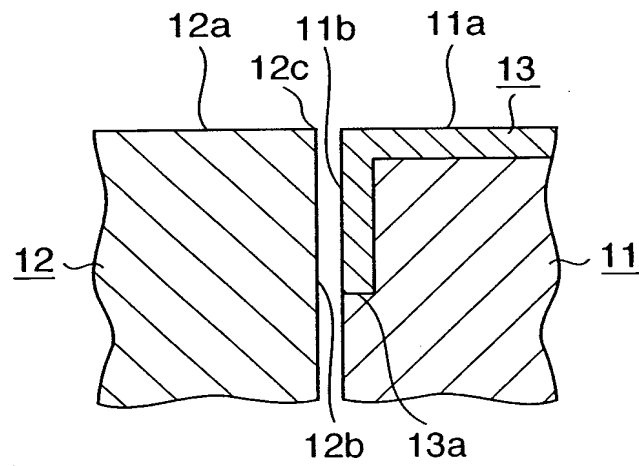
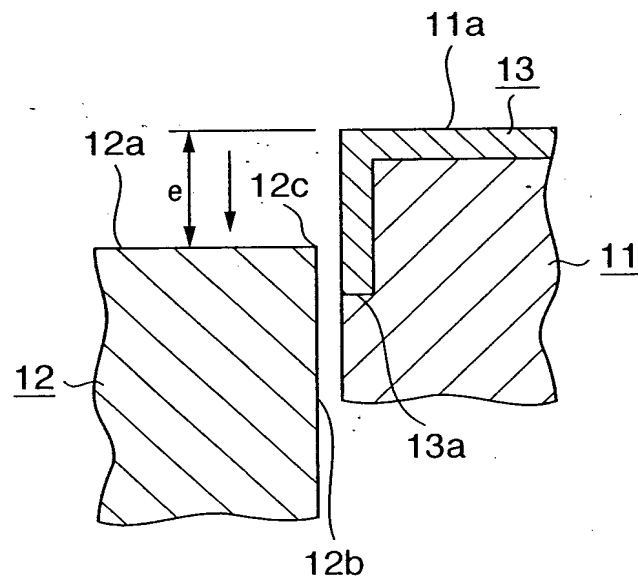


FIG. 2B



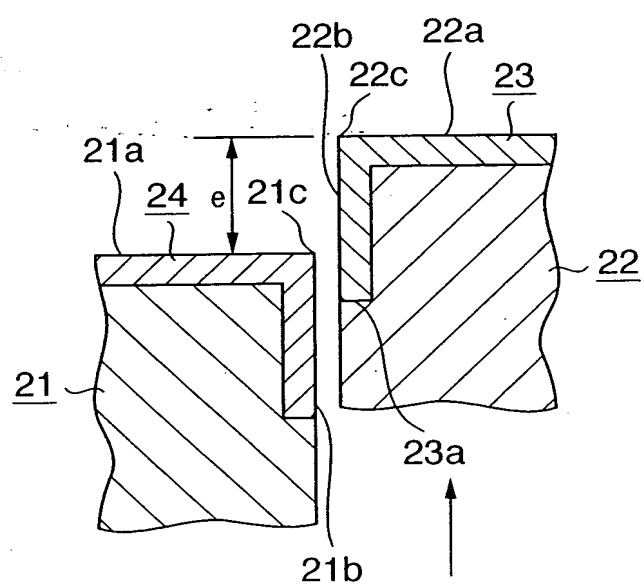


FIG. 4

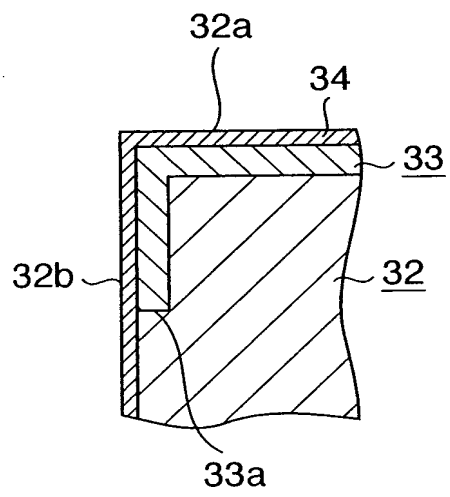


FIG. 5

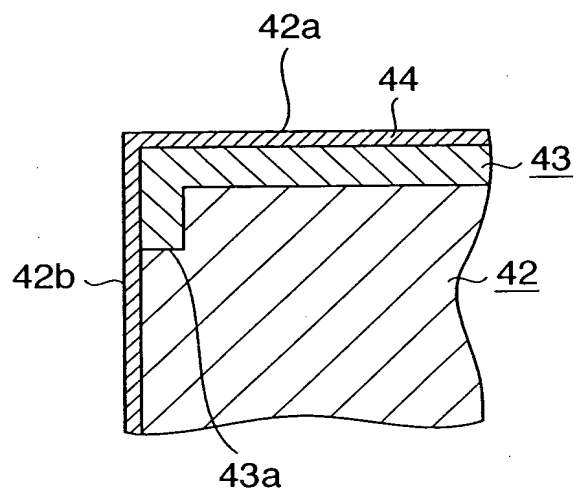


FIG. 6

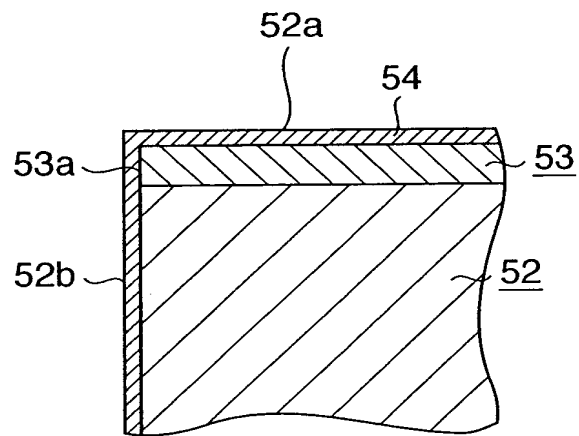


FIG. 7

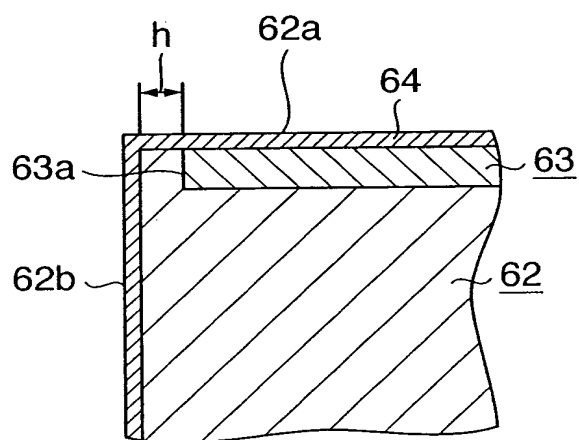


FIG. 8

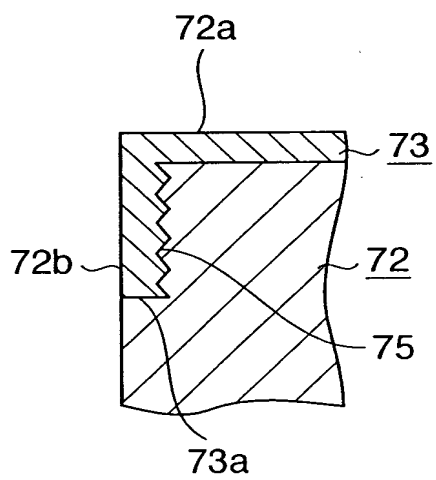


FIG. 9

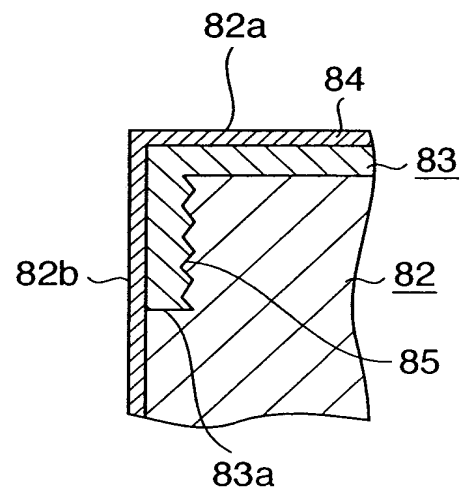


FIG. 10

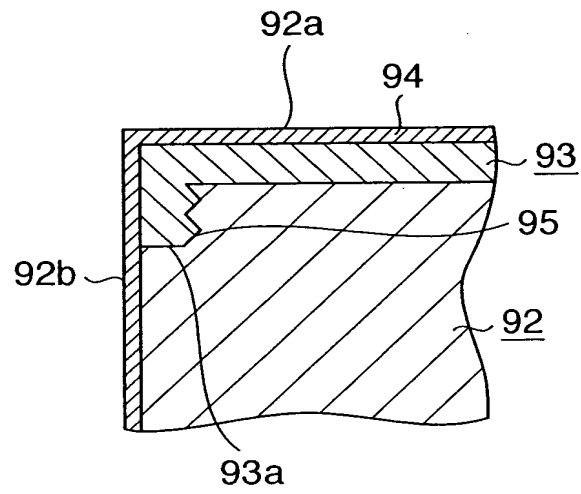


FIG. 11

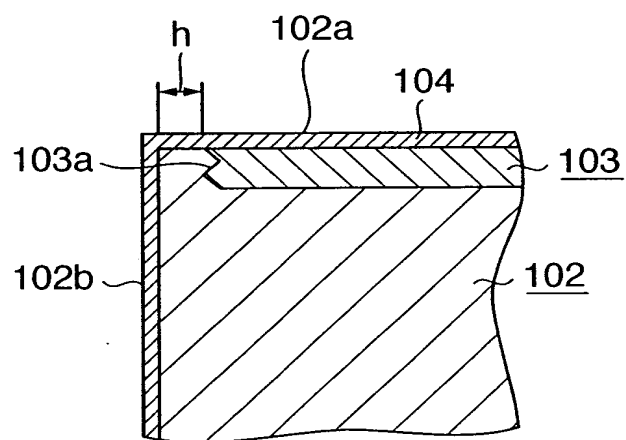


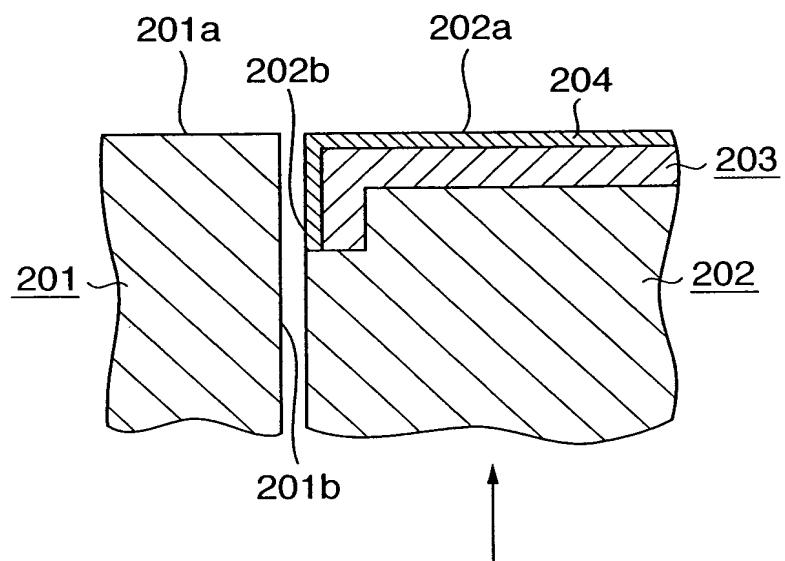
FIG. 12

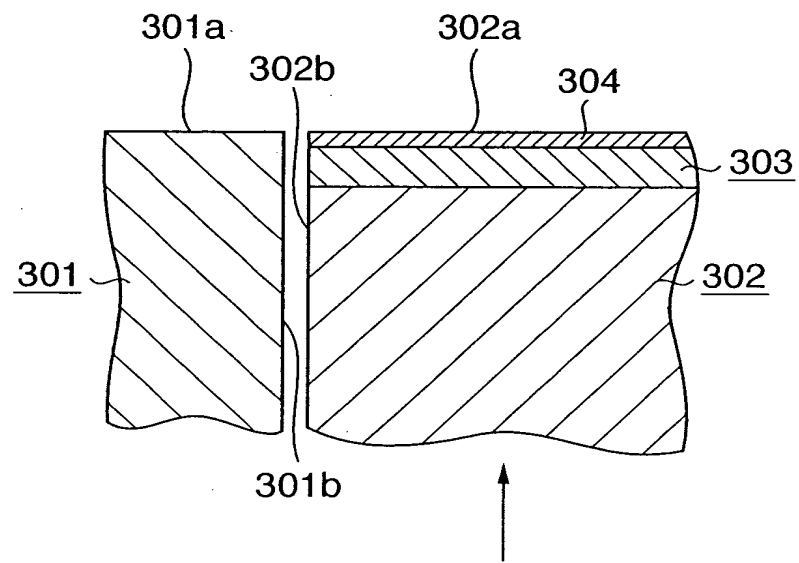
FIG. 13

FIG. 14

	ARRANGEMENT OF SLIDING MEMBER	ARRANGEMENT OF ADJACENT MEMBER	NUMBER OF TIMES OF INJECTION MOLDING BEFORE PEELING OCCURRED
EXAMPLE 1	FIG. 1	FIG. 1	10,000 OR MORE
EXAMPLE 2	//	FIG. 5	//
EXAMPLE 3	//	FIG. 6	//
EXAMPLE 4	//	FIG. 7	//
EXAMPLE 5	//	FIG. 10	//
EXAMPLE 6	FIG. 4	FIG. 1	//
EXAMPLE 7	//	FIG. 5	//
EXAMPLE 8	//	FIG. 6	//
EXAMPLE 9	//	FIG. 7	//
EXAMPLE 10	//	FIG. 10	//
EXAMPLE 11	FIG. 8	FIG. 1	//
EXAMPLE 12	//	FIG. 5	//
EXAMPLE 13	//	FIG. 6	//
EXAMPLE 14	//	FIG. 7	//
EXAMPLE 15	//	FIG. 10	//
EXAMPLE 16	FIG. 9	FIG. 1	//
EXAMPLE 17	//	FIG. 5	//
EXAMPLE 18	//	FIG. 6	//
EXAMPLE 19	//	FIG. 7	//
EXAMPLE 20	//	FIG. 10	//

FIG. 15

	ARRANGEMENT OF SLIDING MEMBER	ARRANGEMENT OF ADJACENT MEMBER	NUMBER OF TIMES OF INJECTION MOLDING BEFORE PEELING OCCURRED
EXAMPLE 21	FIG. 5	FIG. 1	10,000 OR MORE
EXAMPLE 22	//	FIG. 5	//
EXAMPLE 23	//	FIG. 6	//
EXAMPLE 24	//	FIG. 7	//
EXAMPLE 25	//	FIG. 10	//
EXAMPLE 26	FIG. 6	FIG. 1	//
EXAMPLE 27	//	FIG. 5	//
EXAMPLE 28	//	FIG. 6	//
EXAMPLE 29	//	FIG. 7	//
EXAMPLE 30	//	FIG. 10	//
EXAMPLE 31	FIG. 10	FIG. 1	//
EXAMPLE 32	//	FIG. 5	//
EXAMPLE 33	//	FIG. 6	//
EXAMPLE 34	//	FIG. 7	//
EXAMPLE 35	//	FIG. 10	//
COMPARATIVE EXAMPLE 1	FIG. 12	FIG. 12	13
COMPARATIVE EXAMPLE 2	FIG. 13	FIG. 13	122

FIG. 16

	PROTECTIVE COAT MATERIAL	COAT FORMATION METHOD	COAT THICKNESS	NUMBER OF TIMES OF INJECTION MOLDING BEFORE PEELING OCCURRED
EXAMPLE 36	Ni-P	ELECTROLESS PLATING	※	※
EXAMPLE 37	TiC	PHYSICAL VAPOR DEPOSITION	1 μ m	10,000 OR MORE
EXAMPLE 38	TiN	PHYSICAL VAPOR DEPOSITION	//	//
EXAMPLE 39	TiCN	CHEMICAL VAPOR DEPOSITION	//	//
EXAMPLE 40	CrN	PHYSICAL VAPOR DEPOSITION	//	//
EXAMPLE 41	ZrN	PHYSICAL VAPOR DEPOSITION	//	//
EXAMPLE 42	SiC	CHEMICAL VAPOR DEPOSITION	//	//
EXAMPLE 43	DIAMOND	CHEMICAL VAPOR DEPOSITION	//	//
EXAMPLE 44	Al ₂ N ₃	CHEMICAL VAPOR DEPOSITION	//	//

※ UNEVALUATED BECAUSE COAT THICKNESSES OF PORTION COATED WITH HEAT INSULATING COAT AND UNCOATED PORTION WERE NOT EVEN